

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 7745**

Shoriki NARITA et al. : Docket No. 2003-1226

Serial No. 10/651,103 : Group Art Unit 2825

Filed August 29, 2003 : Examiner Igwe U. Anya

BUMP FORMING APPARATUS FOR CHARGE : **Mail Stop: AMENDMENT**
APPEARANCE SEMICONDUCTOR SUBSTRATE,
CHARGE REMOVAL METHOD FOR CHARGE
APPEARANCE SEMICONDUCTOR SUBSTRATE,
CHARGE REMOVING UNIT FOR CHARGE
APPEARANCE SEMICONDUCTOR SUBSTRATE,
AND CHARGE APPEARANCE SEMICONDUCTOR SUBSTRATE

PETITION FOR ONE-MONTH EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Petition hereby is made for a one month extension of time to respond to the communication of
July 27, 2004.

The fee of \$110.00 is

☒ (X) submitted herewith.

☐ () to be charged to Deposit Account No. 23-0975. A duplicate copy of this Petition is enclosed.

☐ () Small entity status of this application is established by a Small Entity Status Assertion which

☐ () is enclosed.

☐ () has been previously submitted.

11/30/2004 FHETEKI1 00000133 10651103

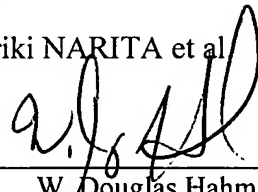
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110.00 OP

Respectfully submitted,

Shoriki NARITA et al

By


W. Douglas Hahm

Registration No.44,142

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November 29, 2004

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975